

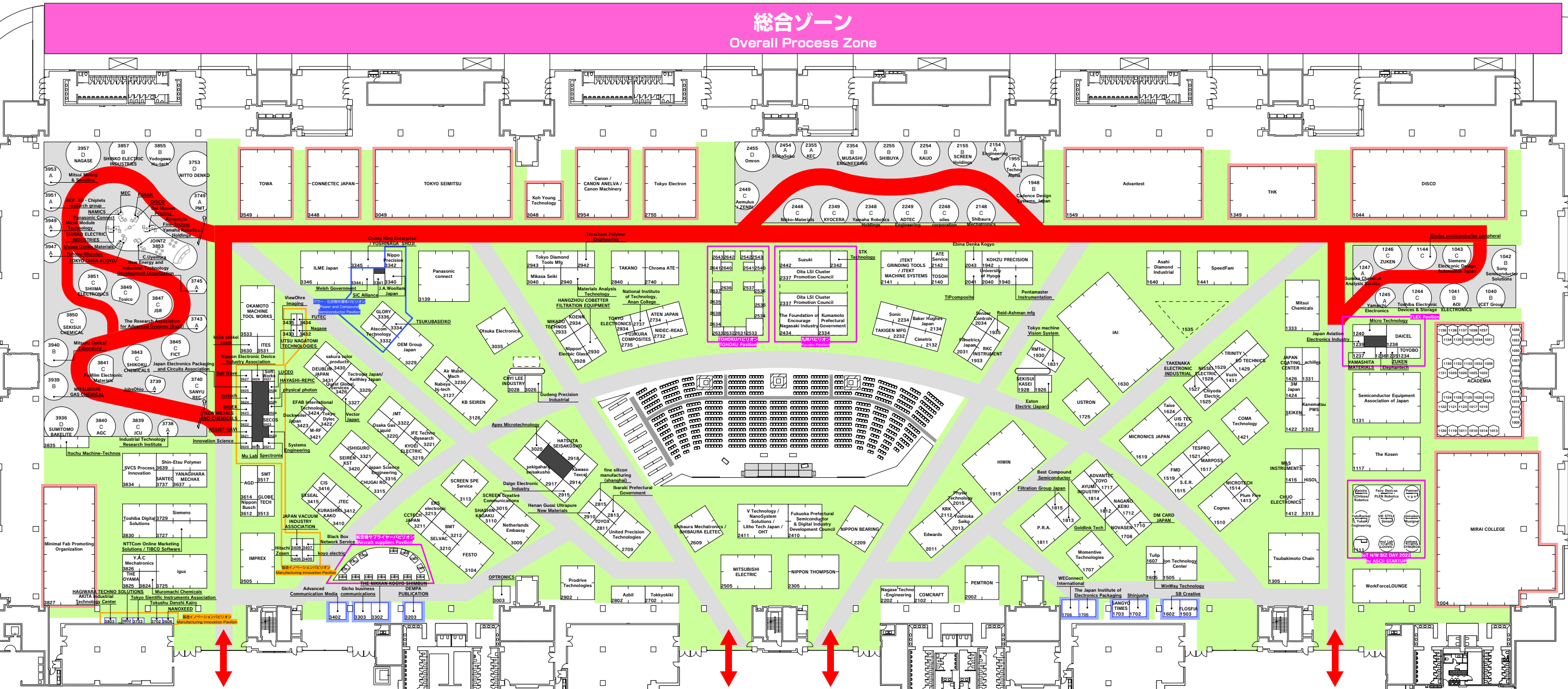
- Booths which are located along the walls of the hall (Size - 4 booth units or above) : 6m or less (*shown as pink line below)
- Booths which are located a low-ceiling part of the hall : 3m or less (*shown as blue line below)
- Booths which are located along walls of the hall (Size - 1-3 booth units) and all others : 4.5m or less
- Booths which are in Pavilion area (Size - 2m x 1m / 2m x 2m) : 2.7m or less
- Booths which are in Pavilion area (Size - over 9m) : 4.5m or less

Hall 3

Hall 2

Hall 1

総合ゾーン Overall Process Zone



ACADEMIA	
1009	National Institute of Technology, Sasebo College, Semiconductor Process Group
1010	Iwate University Akira Yamauchi Laboratory
1011	Aoyama Gakuin University Koh Laboratory
1012	The University of Electro-Communications TSUKUMOTO Laboratory
1013	The University of Electro-Communications Sawada Laboratory
1014	Aoyama Gakuin University, Ishihara Laboratory
1015	Tokai University, Hidekazu Tsuchiya Laboratory
1016	Tokyo Metropolitan University, Micro-Mechanism Laboratory
1017	Nagoya University, Hata Laboratory
1018	Tokyo University of Science Kawahara Laboratory
1019	Tottori University Microelectronics Engineering Laboratory
1020	Tokyo Denki University Shinoda Laboratory
1021	Tokushima University Yotsuyanagi Laboratory
1022	Hiroshi University Imai Laboratory
1024	Shizuoka University Computer System Lab.
1025	Utsunomiya University, Higashibagchi Laboratories, Research Center for Nano-Electronics
1026	Tokyo City University, Advanced Laboratories, Research Center for Nano-Electronics
1027	Ibaraki University Semiconductor Laboratory
1028	Tokai Univ. Kuwahata Lab.
1029	Chiba University, Aoki Lab
1030	University of Yamanashi, Muranaka Lab.
1031	Nihon University Saito Laboratory
1032	Saga University, Hayama Electronics Laboratory
1033	Tokyo University of Science, Optoelectronics Laboratory
1034	Nihon University, Micro Design Laboratory
1035	Yokohama National University, Oya Laboratory
1036	Waseda University, Umezau Laboratory
1037	Shimane University Fujita-Yoshida Laboratory
1038	TOYOHASHI UNIVERSITY OF TECHNOLOGY, Integrated Biosensor and MEMS Group
1119	Yokohama National University Ito Laboratory
1120	Osaka University Yamamura Laboratory
1121	Tokyo University of Agriculture & Technology Ogi Research Group
1122	Niigata University Abe/Sobagawa Laboratory
1123	Tokyo University of Agriculture and Technology, Kanehashi Research Group
1124	Tohoku University, Tanaka Shuji Laboratory
1125	Saga University, Kasu (Power Semiconductor) Laboratory
1126	Kyushu University, Takai Laboratory
1130	Kyushu Institute of Technology, Tamokuro Laboratory
1131	Saitama University IKENO Lab.
1132	Tokyo University of Agriculture and Technology, Nakayama Laboratory
1133	Tokyo City University, Integrated System Laboratory
1134	Hosei University, Research Center of Ion Beam Technology
1135	University of Hyogo, Toyoda Laboratory
1136	Tohoku University, AIM, School of Engineering
1137	Tokyo University of Science, Iiyu Laboratory
1138	Yokohama National University Ohtake Laboratory

MIRAI COLLEGE	
BORZE	Shibaura Mechatronics
2533	New Industry Creation Hatchery Center, Tohoku University
2534	Fukuda Crystal Laboratory
2535	Pan Solution Technologies
2536	Towa Industry
2537	Tohoku University, Center for Innovative Integrated Electronic Systems
2540	Toei Scientific Industrial
2541	Tamaoka Engineering
2542	NTK CERATEC
2543	STORX
2544	Kobayashi Seiki
2545	O-TEC
2546	AIO PRECISION
2547	Saito Optical Science
2548	TAMAOKA ENGINEERING
2549	AOS
2550	AIKOFINETEC
2551	Techno Quartz
2552	Adamant Namiki Precision Jewel
2553	GMIC HILLSTONE
2554	ENA KIKI
2555	TTO

TOHOKU Pavilion	
2533	New Industry Creation Hatchery Center, Tohoku University
2534	Fukuda Crystal Laboratory
2535	Pan Solution Technologies
2536	Towa Industry
2537	Tohoku University, Center for Innovative Integrated Electronic Systems
2540	Toei Scientific Industrial
2541	Tamaoka Engineering
2542	NTK CERATEC
2543	STORX
2544	Kobayashi Seiki
2545	O-TEC
2546	AIO PRECISION
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2552	Adamant Namiki Precision Jewel
2553	GMIC HILLSTONE
2554	ENA KIKI
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Aircraft suppliers Pavilion	
3204	WADA AIRCRAFT TECHNOLOGY
3205	Yoshimasu Seisakuho
3206	Hibiki Seiki
3207	HANSHIN METALS
3208	Kumabou Metal
3209	nercoge
3210	National Institute of Technology, Matsuyama College
3211	Mitsuru Seisakuho
3212	Mitsuru Seisakuho
3213	Shimizu Precision Manufacturing Limited Kobe
3214	TechLab
3215	Tamavakin
3216	SOUWA-TEC
3217	ENA KIKI
3218	TTO

THEKOKEN	
National Institute of Technology, Asahikawa College	
National Institute of Technology, Ishikawa College	
National Institute of Technology, Ibaraki College	
National Institute of Technology, Kanagawa College	
National Institute of Technology, Kagawa College Takuma Campus	
National Institute of Technology, Miyazaki College	
National Institute of Technology, Niigata College	
National Institute of Technology, Oita College	
National Institute of Technology, Okinawa Prefecture College	
National Institute of Technology, Oshana College	
National Institute of Technology, Ichinoseki College	

Bound for RINKAI Line YURIKAMOME Bus

=Aisle

E4-5H Floor Plan

As of November 08, 2022

December 14(Wed) ▶ 16(Fri)

10:00-17:00

Tokyo Big Sight East Exhibition Halls Conference Tower Organized : SEMI®

- [Booth Decoration Height Limits]**
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Hall 5

Hall 4

Quantum	JSR
Quantum	Sumitomo Heavy Industries
Quantum	Formfactor
Quantum	blueqat
Quantum	SEMI Quantum Computer Council
Quantum	Keylight Technologies Japan
Quantum	Zurich Instruments
Quantum	National Institute of Advanced Science and Technology (AIST)

■ =Aisle

S=1:600(A3)
2022.11.08